

PATENT Docket No. SJO920010058US1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT(S):

TSANN LIN

SERIAL NO.:

10/066,835

FILING DATE:

FEBRUARY 4, 2002

TITLE:

IN-SITU OXIDIZED FILMS FOR USE AS GAP LAYERS FOR A SPIN-VALVE

SENSOR AND METHODS OF MANUFACTURE

EXAMINER:

KEVIN M BERNATZ

GROUP ART UNIT:

1773

ATTY. DKT. No.:

SJO920010058US1

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on June 23, 2004.

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